

Title (en)

CU-NI-SI-BASED ALLOY FOR ELECTRONIC MATERIAL

Title (de)

LEGIERUNG AUF CU-NI-SI-BASIS FÜR ELEKTRONISCHES MATERIAL

Title (fr)

ALLIAGE À BASE DE CU-NI-SI POUR UN MATERIAU ÉLECTRONIQUE

Publication

EP 2154257 B1 20161005 (EN)

Application

EP 08739256 A 20080328

Priority

- JP 2008056138 W 20080328
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Abstract (en)

[origin: EP2154257A1] An object of the present invention is to provide a Corson alloy having significantly improved characteristics, i.e. high strength and high electrical conductivity, by enhancing the effect of addition of Cr to a Cu-Ni-Si system alloy. There is provided a copper alloy for electronic materials comprising 1.0-4.5% by mass Ni, 0.50-1.2% by mass Si, 0.003-0.3% by mass Cr wherein the weight ratio of Ni to Si satisfies the expression: $3\#Ni/Si\#\#5.5$, and the balance being Cu and incidental impurities, wherein particles of Cr-Si compounds having a size of 0.1 μm to 5 μm are dispersed in the alloy and the dispersed particles having an atomic concentration ratio of Cr to Si of 1 to 5 and a dispersion density of no more than $1\times10^6 /mm^2$.

IPC 8 full level

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Cited by

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